



Substitute for Form 1449A/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

Application Number 10/802,139

Filing Date March 17, 2004

First Named Inventor Kazuhiko OMOTE

Group Art Unit 2882

Examiner Name Krystyna Suchecki

Sheet 1 of 1

Attorney Docket Number 04176/RPM

OTHER PRIOR ART - NON-PATENT LITERATURE DOCUMENTS

Examiner Initials ¹	Cite No. ¹	Include name of author (in CAPITAL LETTERS), title of article, title of item, date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
W		R. Baudouin-Savois, et al., "A new UHV diffractometer for surface structure and real time molecular beam deposition studies with synchrotron radiations at ESRF," Nuclear Instruments and Methods in Physics Research B 149 (1999), pp. 213-227	
RB		H. Oyangi, et al., "A new apparatus for surface x-ray absorption and diffraction studies using synchrotron radiation," Review of Scientific Instrument 66, December, 1995, Woodbury, New York, U.S.A., pp. 5477-5485	
[Large diagonal line drawn across the empty row]			
Examiner Signature			Date Considered 11/04/05

¹ EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

² Unique citation designation number. Place a check here if English translation is attached.

DATE MAILED: October 12, 2005